

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
John MacNeil et al. : Attn: Applications Branch
Serial No. (New) : Attorney Docket No. WLJ.070D
Filed: July 15, 2003 :

For: METHODS AND APPARATUS FOR FORMING A FILM ON A SUBSTRATE

INFORMATION DISCLOSURE STATEMENT
(SUBMISSION WITH CONTINUATION-IN-PART OR
RULE 1.53(b) CONTINUATION OR DIVISIONAL APPLICATION)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §§ 1.97 and 1.98, applicant(s) hereby submit(s) an Information Disclosure Statement for consideration by the Examiner.

I. LIST OF PATENTS, PUBLICATIONS OR OTHER INFORMATION

The patents, publications or other information submitted for consideration by the Office are listed on PTO-1449 form(s), attached hereto.

II. REFERENCES PREVIOUSLY CITED OR SUBMITTED

Pursuant to 37 C.F.R. § 1.98(d), consideration of information listed on the PTO-1449 form(s) is requested since any patents, publications or other information which are listed on the PTO-1449 form(s) but for which copies are not enclosed herewith, were previously cited by or submitted to the PTO in one of the following applications which has been relied upon for an earlier filing date under 35 U.S.C. § 120:

U.S. Serial Number

09/760,820

U.S. Filing Date

January 17, 2001



III. FEES

This Information Disclosure Statement is being filed concurrent with the filing of a continuation-in-part, continuation or divisional patent application; therefore, no fee is required.

If the Examiner has any questions concerning this IDS or requires a copy of any of the references cited but not provided, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 50-0238.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 50-0238 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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Dated: July 15, 2003

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*ATTY DOCKET NO.
WLJ.070DSERIAL NO.
NEW**John MacNeil et al.**FILING
July 15, 2003GROUP
To Be Assigned**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	5,514,604	05/07/1996	BROWN			
	B	5,244,698	09/14/1993	ISHIHARA et al.			
	C	4,647,472	03/03/1987	HIRAKI et al.			
	D	5,635,423	06/03/1997	HUANG et al.			
	E	5,225,032	07/1993	GOLECKI			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	F	EP 1 059 664 A2	12/13/2000	EPO				
	G	WO 99/56310	04/11/1999	PCT				
	H	WO 99/33102	07/01/1999	PCT				
	I	WO 00/19498	04/06/2000	PCT				
	J	WO 99/41423	08/19/1999	PCT				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		K	"Dual-Damascene Challenges Dielectric Etch", Semiconductor International, August 1999, pages 69-72.

EXAMINER**DATE CONSIDERED**

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

